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In re Application of:  
Stiblert *et al*  
Application No.: **10/587,482**  
PCT No.: PCT/SE2005/000100  
Int. Filing Date: 28 January 2005  
Priority Date: 29 January 2004  
Atty. Docket No.: MLSE 1070-1  
For: A Method for Measuring the  
Position of a Mark in a Deflector  
System

STATUS REQUEST

Dear Mr. Beffel:

This letter is in response to your communication received 03 January 2008 requesting the status of the Filing Receipt for U.S. national application **10/587,482**.

The United States Designated Office/Elected Office (DO/EO) records appear to show that a Notification of Missing Requirements under 35 U.S.C. 371 (M905) was prepared and issued on 04 February 2008. The applicant should be receiving the Notification of Missing Requirements in due course.

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